



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. 09/603,147
Filing Date June 23, 2000
Inventor John T. Moore et al.
Assignee Micron Technology, Inc.
Group Art Unit 2813
Examiner Kielin, Erik J.
Attorney's Docket No. MI22-1443
Title: Capacitor Constructions, DRAM Constructions and Semiconductive
Material Assemblies

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

To: Mail Stop RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

From: Jennifer J. Taylor, Ph.D. (Tel. 509-624-4276; Fax 509-838-3424)
Wells St. John P.S.
601 W. First Avenue, Suite 1300
Spokane, WA 99201-3828

Dear Sir:

The Examiner's attention is directed to the references which are listed on
the attached Form PTO-1449 and copies of which are attached.

Citation of these references is respectfully requested.

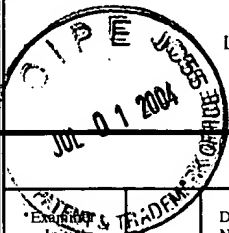
Respectfully submitted,

Dated:

July 1, 2004

By:

Jennifer J. Taylor
Jennifer J. Taylor, Ph.D.
Reg. No. 48,711

Form PTO-1449		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. M122-1443	SERIAL NO. 09/603,147			
<div style="float: left; width: 150px; text-align: center;">  </div> <div style="clear: both;"></div> <p>LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)</p>				APPLICANT John T. Moore et al.				
				FILING DATE June 23, 2000		GROUP 2813		
U.S. PATENT DOCUMENTS								
Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate		
	AA							
	AB							
	AC							
	AD							
	AE							
	AF							
	AG							
	AH							
	AI							
	AJ							
	AK							
	AL							
FOREIGN PATENT DOCUMENTS								
		Document Number	Date	Country	Class	Subclass	Translation	
							Yes	No
	AM							
	AN							
	AO							
	AP							
	AQ							
OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)								
	AR		John L. Vossen, et al., "Thin Film Processes", Academic Press, 1978, p. 290					
	AS							
	AT							
EXAMINER				DATE CONSIDERED				
<p><small>*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.</small></p>								